Charge distribution and screening in layered graphene system s.

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The charge distribution induced by external elds in nite stacks of graphene planes, or in sem iin nite graphite is considered. The interlayer electronic hybridization is described by a nearest neighbor hopping term, and the charge induced by the self consistent electrostatic potential is calculated within linear response (RPA). The screening properties are determined by contributions from inter- and intraband electronic transitions. In neutral system s, only interband transitions contribute to the charge polarizability, leading to insulating-like screening properties, and to oscillations in the induced charge, with a period equal to the interlayer spacing. In doped system s, we nd a screening length equivalent to 2-3 graphene layers, superim posed to signi cant charge oscillations.

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I. IN TRODUCTION.

Electronically charged systems made up of a few graphene layers are being intensively studied^{1,2,3,4,5,6,7,8}, as well as the elects of charge accumulation on the surface of bulk graphite^{9,10}. Hence, the study of the charge distribution in nite stacks of graphene layers, or in seminin nite graphite, is a problem of current interest.

It is known that screening in a single graphene layer shows anom alous properties, due to the vanishing of the density of states at the Ferm i level in neutral graphene^{11,12}. A stack of graphene planes where electrons are con ned to each layer also shows unusual screening properties¹³. In addition, defects and edges can lead to self doping e ects in a single graphene layer¹⁴.

The screening properties of bulk graphite were initially investigated describing the system as a stack of two dimensional electron uids electrostatically coupled¹⁵. The electronic hybridization between layers was not included in the model. The simplest extension that takes interlayer hybridization into account includes a tight binding hopping element between orbitals at C arbon atoms which are nearest neighbors in adjacent layers. The introduction of this term changes substantially the electronic structure of bulk graphite¹⁶, and also of system s containing few graphene layers^{16,17}.

The charge distribution in system s under an applied eld must be calculated self consistently. Such a calculation, using the interlayer hopping model described above, has been carried out for a graphene bilayer¹⁸. In the following, we calculate the charge distribution in graphene stacks of arbitrary width, and in semi in nite graphite. We calculate the electrostatic potential self consistently, and assume that the induced charge can be obtained using linear response theory. These assumptions amount to the R andom P hase Approximation, applied to the model mentioned earlier. A similar calculation for a bilayer can be found in¹⁸, and it is in reasonable agreement with more involved numerical calculations.

W e use, as a starting point, the calculations of the unpperturbed electronic structure of nite graphene stacks, and sem in nite graphite, reported in^{16} . We do

not study the e ects of other interlayer hoppings, disorder, or other e ects related to interactions. We also do not consider deviations from Bernal stacking, f1212 which can alter the electronic structure at the Fermi $evel^{16}$.

The following section presents the model to be studied. We discuss then screening in semiin nite graphite, and we analyze a nite graphene stack next. Section IV presents the main conclusions of our work. It also contains a discussion of the limits of validity of the results presented here, and their relation to previous work.

II. THE MODEL.

A. Electrostatic e ects.

W e analyze the charge distribution at the surface layers of a system with many graphene layers coupled electrostatically to an external gate. The system is schematically shown in Fig.[1]. A potential V is applied between the gate and the graphene stack. An electric eld, $E = V = l_{r}$, where l is the distance between the gate and the stack. The electric potential beyond the gate is assum ed to be zero, so that the voltage at the gate is V . Using Gauss law we can write the total charge density per unit area in the stack, n as en = 4 E. This charge is distributed among the layers, n1;n2;n3; where label 1 stands for the outerm ost layer. The electric eld in the region between layers 1 and 2 is $E_{1,2} = 4$ en₁=d, where d is the interlayer distance. This eld detrm ines the potential in layer 2. Extrapolating this procedure to all layers, we nd that the electrostatic potential in layer i satis es:

$$\sum_{k=1}^{k^{1}} n_{k}$$
 (1)

or, alternatively:

i

$$1 \quad 2_{i} + _{i+1} = 4 \quad e^{2} dn_{i}$$
 (2)

We include the possible e ects of a nite dielectric constant, $_0$, into the de nition of the electrostatic charge,

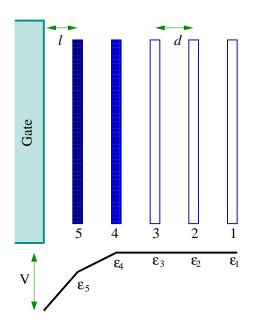


FIG.1: (Color online). Sketch of the system studied in the text. The two layers closest to the gate are charged, and lead to the electrostatic potential shown in the lower part.

 e^2 .

B. Linear response approxim ation.

W e analyze the system within the Hartree approxim ation, and we assume that the induced charge can be well approximated using by linear response theory (R andom P hase Approximation).

The induced electron density can be written, using linear response theory, as:

$$n_{i} = \begin{array}{c} X \\ i; j \\ j \end{array}$$
(3)

where $_{ij}$ is a static susceptibility which describes the charge density induced at layer i when the potential at layer j is $_{j}$. The calculation of these susceptibilities is given by diagram s like the one shown in Fig.[2]. Their value is:

where the interm ediate empty and occupied states are labelled by their moments, $K_k; k_2; K_k^0; k_2^0$, and /i) and j are layer indices. The quantities $\begin{cases} K_k; k_2 \\ i \end{cases}; \begin{cases} K_k; k_2 \\ j \end{cases}; \begin{cases} K_k; k_2 \\ i \end{cases}$ and $\begin{cases} K_k; k_2 \\ j \end{cases}$ in eq.(4) are the amplitudes of the wave-functions on layers i and j respectively. We will only consider charge distributions which are hom ogeneous in

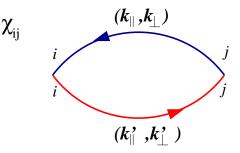


FIG.2: (Color online. Charge susceptibility required in order to calculate the induced charge.

the directions parallel to the layers, so that the parallel momentum transfer in the diagram in Fig.[2] vanishes, $\mathbf{q} = \mathbf{K}_k \quad \mathbf{K}_k^0 = 0.$

C. Electronic structure.

W e describe the electronic levels of the graphene stack by means of a tight binding model using the orbitals at each C atom . W e consider a hopping between orbitals in atom s which are nearest neighbors within a given layer, t = 2:7eV, and a hopping between atoms in adjacent layers which are also nearest neighbors, $t_2 = 0.3 \text{eV}$. We study mostly the Bernal stacking, so that the hopping term connects half of the orbitals in a given layer with half of the orbitals in the two nearest layers. At long wavelengths and near half lling the in plane dispersion is well approxim ated by the continuum D irac equation, described in terms of the Fermi velocity, $v_F = 3ta=2$, where a = 1:4A is the distance between Carbon atom s. D etails of the model, and of the band structure for stacks with di erent number of layers and stacking order are given in¹⁶.

The system has translational invariance in the direction parallel to the layers, so that the parallelm om entum, $\kappa_k = (k_x; k_y)$ is conserved. If the stack is in nite, the momentum norm alto the layers, k_2 , is also conserved.

In an in nite stack with only nearest neighbor coupling between layers, all layers are equivalent (in general, a description of the Bernal stacking requires two inequivalent layers). Then, ham iltonian for each momentum decouples in a set of 2 2 m atrices, whose entries correspond to B loch states de ned in the two inequivalent sublattices of each layer. For a given corner of the Brillouin zone, the ham iltoonian can be written as:

$$H_{\tilde{K}_{k};k_{2}} = \begin{array}{c} 2t_{2}\cos(k_{2} d) & v_{F}(k_{x} + ik_{y}) \\ v_{F}(k_{x} ik_{y}) & 0 \end{array}$$
(5)

The diagonal terms in eq.(5) are determined by the interlayer hopping, so that H $_{22} = 0$, as one of the sublattices is decoupled from the neighboring layers. The ham iltonian in eq.(5) reduces to the D irac equation for $t_2 = 0$.

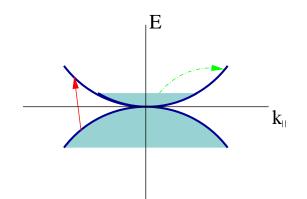


FIG. 3: (Color online). Sketch of the inter- and intraband transitions whose separate contributions to the charge susceptibility is analyzed in the text.

The low energy eigenenergies can be approximated as:

$$\frac{v_F^2 \breve{X}_k \breve{f}}{2t_2 \cos(k_2 d)}$$
(6)

This approximation fails for $k_{?} d = 2$, where the bands show a linear dependence on K_{k} .

The allowed momenta in a nite stack with N layers are quantized, $k_2^n = (n) = [d(N + 1)]^{16}$. In addition, the amplitude of the wavefunctions go to zero as sin (ik₂ c) at layer i from the surface. The electronic wavefunctions in a nite stack are described in Appendix A.

D. Calculation of the charge susceptibility.

The response of the electrons at both inequivalent corners of the Brillouin Zone is the same, so that we need to calculate the polarizability at one K point.

The charge susceptibility includes contributions from transitions between the valence and conduction bands, interband transitions, and transitions within the conduction band, intraband transitions, as schematically depicted in Fig. β].

We consider isst the interband transitions, involving an occcupied state in the valence band and an empty state in the conduction band. We neglect the contribution from the states with $k_2 d = 2$, and we use the approximate dispersion relation given in eq.(6). Then, the susceptibilities in eq.(4) can be written an integral over R_k , and k_2 and k_2^0 . The electronic states in a sem in nite stack can also be characterized by a perpendicular momentum, k_2 , although the corresponding wavefunctions are no longer running waves. Near the surface of a sem iin nite stack, the amplitudes in eq.(4) are:

$$\underset{i}{\overset{\breve{k}_{k},\breve{k}_{?}}{i}} = C \sin(ik_{?} d)$$
 (7)

where C is a norm alization constant. Note that, although one needs in principle to de ne the amplitude as a two component spinor in each layer, the low energy states considered here, eq.(6), have vanishing amplitude on the sublattice connected by the interlayer hopping t_2^{-16} .

Using eq.(7), we nally obtain:

$$\frac{8}{ij} \frac{t_2}{V_F^2} = \frac{2}{-2} \frac{2}{-2} \frac{2}{-2} \frac{(3)^{-2}}{-2} = \frac{2}{-2} \frac{2}{-2} \frac{(3)^{-2}}{-2} \frac{($$

where $_0$ is a low energy cuto to be specified later, and we write = k d and $^0 = k_2^0 d$. In a nite stack, these integrals over k_2 and k_2^0 must be replaced by sum s over the quantized momenta, see section [IIIB]. The prefactor \sim_{ii}^{inter} in eq.(8) is defined as:

$$\sim_{ij}^{inter} = \frac{1}{2} \begin{bmatrix} Z & _{=2} & Z & _{=2} \\ d & _{=2} \end{bmatrix} = \frac{1}{2} \begin{bmatrix} Z & _{=2} & _{=2} \\ d & _{=2} \end{bmatrix} = \frac{1}{2} \begin{bmatrix} \sin(i) \sin(j) \sin(i^{0}) \sin(j^{0}) \cos(i) \cos(i^{0}) \\ \cos(i) \cos(i^{0}) \end{bmatrix}$$
(9)

The values of \lim_{ij} near the boundary of the stack are plotted in Fig.[4] The limiting bulk values:

$$\gamma_{m + n fm}^{\text{inter}} = \gamma_{n}^{\text{inter}} = \frac{1}{4^{2}} \int_{-2}^{2} d \int_{-2}^{2} d \int_{-2}^{2} d \int_{-2}^{2} d \int_{-2}^{0} \frac{\cos[n(0)]\cos(0)\cos(0)}{\cos(0)}$$
(10)

are also shown.

III. RESULTS.

A. Undoped sem iin nite stack.

In a sem in nite stack, su ciently far from the surface, so that the susceptibilities _{ij} have converged towards their bulk values, eqs.(2) and (3) adm it the solution:

$$i = 0 e$$

$$n_i = n_0 e$$
(11)

with:

$$e + e \qquad 2 = 4 \ e^{2} d \qquad e^{n} \qquad \lim_{n = 1} e^{n} \qquad \lim_{n = -1} e^{n} = \frac{8e^{2} dt_{?}}{v_{F}^{2}} \log \frac{t_{?}}{0} \qquad \frac{1 + \cosh(0)}{2\sinh(0)} \arctan \frac{h}{2} \frac{1}{2} \qquad (12)$$

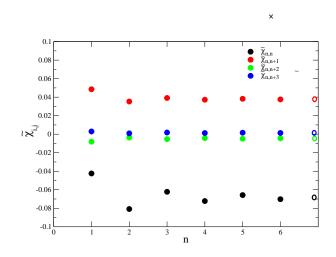


FIG. 4: (Color online). Value of the prefactor in the susceptibilities near the boundary of a stack of graphene planes, see eq.(8). The corresponding bulk values are plotted as open circles on the right.

D etails of the steps involved in the derivation of eq.(12) are given in Appendix B .

In m etallic system s and for ! 1, the right hand side in eq.(12) is equal to $\lim_{k_2 \cdot ! \cdot 0} (k_2; K_k = 0) = D(F)$, where D(F) is the density of states at the Ferm i level in a given layer. Using this result, we obtain the Thom as-Ferm i approximation, $^2 = 4 e^2 dD(F)$ in the limit !0.

For the model for undoped graphite studied here, the rhs. of eq.(12) vanishes as ! 0, and ordinary screening does not take place.

The contribution of the interband transitions to the charge susceptibility is not enough to give a nite charge com pressibility at long wavelengths, leading to a behavior rem iniscent of that of an insulator. Note that, at zero doping, the transitions between occupied and empty states in the limit 0! 0 require a nite energy of order $t_2 \cos()$, except for 0 = 2. These transitions have vanishing weight in the integral which gives the charge compressibility (see Fig.5)). Hence, the charge susceptibility tends to zero at zero energy and $k_2 d! 0$. Note that, on the other hand, the staggered spin and

charge susceptibilities, $k_2 d \in 0$, diverge logarithm ically at ! ! 0^{19} . This divergence is maximal for $k_2 d = .$

Eq.(12) adm its only solutions with > 0 if:

$$\frac{4e^{2}dt_{?}}{v_{F}^{2}}\log\frac{t_{?}}{0} = 6$$
(13)

The scale $_0$ in eq.(8) determ ines the region where the model gives a valid description of a graphene stack. At zero tem perature, it will be determ ined by interlayer hoppings not considered here, disorder, and lifetime broadening due to interaction e ects. At nite tem peratures, the logarithm ic divergence in eq.(8) is cuto by therm al interband excitations, st that $_0$ T. Hence, the screening properties of the model depend on tem perature.

At the surface, the screening by interband transitions is modi ed, as the relative strength of the di erent subbands, as function of $k_{\rm ?}$, is modi ed. The contribution to the real space matrix elements of the susceptibility are given by:

$$\lim_{ij} = \frac{8t_2}{V_F^2} = \frac{2}{v_F^2} d \sin(i)^2 \sin(j)^2 \cos(j)$$
(14)

At nite dopings the density of states of each graphene plane in the model studied here is:

D (_F) =
$$\frac{4t_2}{2v_F^2}$$
 (15)

independent of the carrier concentration. Intraband transitions modify the charge susceptibility ask? ! 0. The charge compressibility becomes nite, leading to a bulk screening length :

$${}^{2} = \frac{16e^{2}dt_{?}}{v_{\rm F}^{2}}$$
(16)

FIG.5: (Color online). Transitions between the valence and conduction bands states for $(k_2 \ k_2^0)c = 0.05$ and $k_2c = 0.4$. The apam eters used are $v_F = 1$ and $t_2 = 0.1$.

-0.2-0.3-0.4-0.401020304050Position

0.3

0.2

0

FIG.6: (Color online). Charge at the surface of a semiin - nite stack, norm alized to one. Only interband transitions are included in the calculation.

In the following, we use the parameters:

$$\frac{e^2}{v_F} = 1$$

$$\frac{t_2 d}{v_F} = \frac{1}{5}$$
(17)

U sing these values, eq.(16) gives a screening lengt due to bulk intraband transitions of about N 2 layers. The screening at the surface, how ever, is modiled and reduced, as shown in eq.(14).

N um erical results, including the full dependence on position of $\sim_{m,m+n}$ are shown in Fig.[6]. We have chosen the parameter $_0$ such that $\log(t_2 = _0) = 6$. The charge oscillates with every second layer. This result is consistent with the logarithm ic divergence of the charge and spin susceptibility for $k_2 d = .$ The induced charge is reduced to less than 10% of the charge in the surface layer in about N 3 5 layers.

B. Finite stacks.

The eqs.(2) and (3) can be solved in a straightforward way for a system with a few layers. The discrete equivalent to the reduced susceptibilities in eq.(9) can be dened as:

$$\sim_{ij}^{inter} = \begin{cases} X^{N} & X^{N} \\ & \sin(k_{?}^{n} di) \sin(k_{?}^{n} dj) \sin(k_{?}^{n^{0}} di) \sin(k_{?}^{n^{0}} dj) \\ & \frac{\cos(k_{?}^{n} d) \cos(k_{?}^{n^{0}} d)}{C_{k_{?}^{n}} C_{k_{?}^{n^{0}}} \cos(k_{?}^{n} d) \cos(k_{?}^{n^{0}} d)} a \end{cases}$$

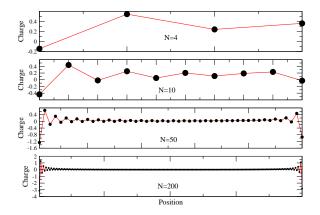


FIG. 7: (Color online). Charge distribution in systems with 4, 10, 50 and 200 graphene layers, norm alized to one.

where $C_{k_{2}^{n}}$ is a norm alization constant:

$$C_{k_{2}^{n}} = \frac{X^{N}}{\sin^{2}(k_{2}^{n} \text{ cl})}$$
 (19)

A nite bilayer can be charged, so that the Ferm i energy does not need to lie exactly between the valence and conduction bands. Then, we have to add to the susceptibility a contribution from intraband transitions at

(18) K_k ! 0. The contribution of each subband is determ ined by its contribution to the total density of states, and it is independent of the position of the Ferm i level. Hence, intraband transitions lead to:

$$_{ij}^{intra} = \frac{2t_{?}}{{}^{2}v_{F}^{2}} \frac{X}{{}_{n}} \frac{\sin^{2}(k_{?}^{n} di) \sin^{2}(k_{?}^{n} dj) j\cos(k_{?}^{n} d) j}{C_{k_{?}^{n}}^{2}}$$
(20)

The charge distribution is given by the equations:

$$i = n_{1} + 4 e^{2}d n_{k}$$

$$k = 1$$

$$n_{1} = n_{0} + \frac{X^{N}}{ij} + \frac{intra}{ij} j$$

$$j = 1$$
(21)

where n_0 is a constant which xes the total density, in turn detrm ined by the applied eld between the gate and the stack.

The diagonal intraband susceptibilities near the surface of a sem iin nite stack satisfy:

$$\sim_{nn}^{\text{intra}} / \int_{=2}^{2} d \sin^{4}(n) \cos(1) =$$
$$= \frac{1}{4(16n^{2} - 1)} + \frac{(1)^{n}}{2n^{2} - 1} + \frac{3}{4}$$
(22)

showing even-odd oscillations as function of the distance to the surface, n, as well as a slow convergence to the bulk limit, n ! 1 .

If we neglect the intraband susceptibility, we nd for a bilayer:

$$_{1} \quad _{2} = \frac{2 e^{2} dn_{0}}{1 2 e^{2} d(_{11} \quad _{12})}$$
(23)

where n is the total carrier density, and $_{11}$ and $_{12}$ are the bilayer interband susceptibilities, de ned using eqs.(18) and (8). By choosing the low energy cuto , $_0$ such that $_0$ = $_{\rm F}$ = ($v_{\rm F}^2 n_0$)=t₂, we recover the results in^{18} to lowest order in n_0 .

Examples of the charge distribution in doped systems with di erent number of layers are shown in Fig.[]. We nd that:

i) The charge distribution is rather hom ogeneous in narrow stacks, and it becomes concentrated at the surfaces for stacks wider than the screening length.

ii) There are oscillations as function of the distance to the surface in wide stacks, as in the case of a sem in nite stack. These oscillations can lead to charge with di erent sign in neighboring layers.

IV. CONCLUSIONS.

We have calculated the charge distribution in stacks of graphene layers in an applied eld. We describe the electronic structure by a tight binding model for the orbitals, which includes hopping between sites which are nearest neighbors in adjacent layers. The self consistent electrostatic potential is obtained assuming linear response theory, so that our approximations amount to the R andom Phase Approximation.

The electronic structure of these systems shows a valence and conduction bands with parabolic dispersion as function of the parallelm om entum, for all values of the perpendicularm om entum. These bands touch at zero energy, which de nest he chemical potential in the undoped case. Finite and in nite stacks are gapless.

The charge susceptibility can be written as a sum of intra- and interband contributions. In a clean, neutral system only interband transitions contribute. In this case, an in nite stack of layers show snon m etallic screening, as the long wavelength charge susceptibility vanishes.

The charge susceptibility for nite momenta perpendicular to the layers shows a logarithm ic divergence at low energies. This divergence is maximal for a wavevector inversely proportional to the distance between the layers, leading to charge oscillations. In addition, the logarithm ic divergence at nite wavevectors in plies that the screening properties of undoped system s can show a depedence on the frequency at which they are probed, or on tem perature.

The charge distribution induced at a surface can be extended overm any layers, and it shows a decaying modulation with a period equal to the distance between the layers.

In doped samples, the long wavelength charge polarizability is nite, and it is dom inated by intraband transitions. We nd that an external eld is screened within 3-5 layers from the surface. The screening length is independent of carrier concentration. The interband transitions lead to oscillations in the induced charge, as in the undoped case. As these uctuations depend logarithm ically on a low energy cuto , they can also show a dependence on tem perature or frequency.

The screening length in doped stacks obtained here depends on the values of the param eters given in (17). Their bulk values are not known with precision²⁰, and it is possible that some of them, like the e ective electric charge or the interlayer hopping, change near an interface. Hence, the value of 3-4 layers over which the charge is delocalized in doped samples is only approximate.

O ur calculation does not take into account e ects such as next nearest neighbor hoppings, disorder, or deviations from linear reponse. The existence of other hoppings, or disorder, will de ne a low energy scale below which the results will no longer be valid.

D eviations from linear response theory depend on the strength of the induced electrostatic potential with respect to the parameters which de ne the band structure, the smaller of which is the interlayer hopping, t_2 , which we have assumed to be t_2 0:1 0:3eV. Typical di erences in electrostatic potentials between adjacent layers are given by i i 1 e² dn, where n is the induced charge per unit area. For n 10^{11} 10^{12} cm², we obtain i i 10³ 10^{12} eV, so that the assumption of

It is interesting to consider the sim ilarities and di erences of this work with the related calculation in¹⁵. In this reference, it was assumed that a low density two dimensional electron gas existed in each layer, and that the electrons could not move between di erent layers. This approximation is equivalent to consider only the diagonal susceptibility, nn, in eq.(8). For the 2DEG, only intraband transitions exist, leading to $_{nn}$ = D ($_{F}$) = $(m = (\sim^2), where n_v is the num ber of valleys. This$ n,, assumption leads to metallic screening, with a decay of the electrostatic potential into the bulk, eq.(12), given by 2 ($e^2 dn_v m$)=(\sim^2). In our case, the existence of a nite density of states near the Ferm i level is a consequence of the nite interlayer hopping, t, as the electronic structure reduces to a stack of decoupled D irac equations in the absence of hopping. The charge oscillations near a surface are directly related to the quantum coherence between stacks induced by the interlayer hopping. Hence, they cannot be obtained in the model used in^{15} .

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APPENDIX A: ELECTRONIC WAVEFUNCTIONS IN FINITE STACKS.

We de ne the amplitude of the wavefunction with parallelm om entum K_k , perpendicular mom entum k_2^n at layer M as a two component spinor:

$$\begin{array}{c} & \vdots \\ & & & \\ &$$

where $_{K_k,k_2^n,M}$ and $_{K_k,k_2^n,M}$ refer to the amplitudes on the A sublattice, whose atom s in di erent layers are nearest neighbors, and the B sublattice, whose atom s in different layers are not connected. In order to satisfy the open boundary conditions at the surfaces of the stack, these amplitudes must be of the form :

$$\begin{array}{ccc} & & & \\ &$$

and:

The low energy eigenvalues, j_{K_k} , k_2^n , j t? are given by:

$$q = \frac{q}{t_{2}^{2} \cos^{2}(k_{2} c) + v_{F}^{2} \tilde{\chi}_{k}^{2}} = \frac{v_{F}^{2} \tilde{\chi}_{k}}{2t_{2}^{2} \cos^{2}(k_{2} c) + v_{F}^{2} \tilde{\chi}_{k}^{2}} \frac{v_{F}^{2} \tilde{\chi}_{k}}{2t_{2} \cos(k_{2}^{n} c)}$$
(A4)

within this low energy approximation, eq.(A3) implies that:

$$\begin{array}{cccc} & & & & & \\ \mathbf{x}_{k}, \mathbf{k}_{2}^{n} & & \mathbf{C}_{k_{2}^{n}}^{1=2} & \\ \mathbf{x}_{k}, \mathbf{k}_{2}^{n} & & \mathbf{0} \end{array}$$
 (A 5)

where
$$C_{k_2^n}^{\perp=2}$$
 is a norm alization constant.

1 0

W e derive the right hand side of eq.(12) using the expressions in eq.(10). The dependence on the layer index

n in eq.(10) is through the factor $\cos[n(^{0})]$. In order to regularize the sum mations over n, we add as mall decaying factor, :

$$\cos[n($$
 ⁰)]! e ^{jn j} $\cos[n($ ⁰)] (B1)

For = 0 in eq.(12) the n dependent part of the sum gives:

$$e^{j_{n}j}e^{j_{n}(0,+0)} = \frac{\sinh(0)}{\cosh(0,-1)} e^{j_{n}(0,+0)} (B2)$$

where, for convenience, we have also incuded a shift, 0. Using this result, we also obtain:

For

The sum mation for \notin 0 in eq.(12) is form ally equivalent to the replacement $_0$! i . Making this substitution, we nd:

r

F (i) =
$$\frac{1 + \cosh(1)}{2 \sinh(1 - 2)} \arctan \sinh \frac{1}{2}$$
 (B4)

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